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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kim, et al. Docket No.: 2003 P 53738 US
Serial No.: 10/720,450 Art Unit: 2891
Filed: November 24, 2003 Examiner: Caridad Everhart
For: MIM Capacitor Structure and Method of Fabrication

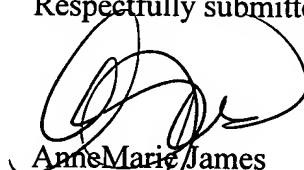
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Information Disclosure Statement (1 original and 1 copy)
Form PTO/SB/08A (1 page), with 16 references cited
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Respectfully submitted,


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